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**RECORDATION FORM COVER SHEET
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Tab settings $\Rightarrow \Rightarrow \Rightarrow$

To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):
Quester Technology, Inc.

Additional name(s) of conveying party(ies) attached? Yes No

2. Name and address of receiving party(ies)
Name: Canon U.S.A., Inc.

Internal Address: _____

Street Address: One Canon Plaza

City: Lake Success State: NY Zip: 11042-1119

Additional name(s) & address(es) attached? Yes No

3. Nature of conveyance:

Assignment Merger

Security Agreement Change of Name

Other _____

Execution Date: July 28, 2003

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: _____

A. Patent Application No.(s) See Attached List (1 page)

B. Patent No.(s) See Attached List

Additional numbers attached? Yes No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Sheldon R. Meyer

Internal Address: _____

Street Address: Fliesler Dubb Meyer & Lovejoy
Four Embarcadero Center, Suite 400

City: San Francisco State: CA Zip: 94111-4156

6. Total number of applications and patents involved:

7. Total fee (37 CFR 3.41).....\$ 40.00

Enclosed

Authorized to be charged to deposit account

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9. Signature.

D. Benjamin Borson *D. Benjamin Borson* 7/28/2003

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Reg. No.: 42,349 Total number of pages including cover sheet, attachments, and documents: 7

Mail documents to be recorded with required cover sheet information to:
Commissioner of Patents & Trademarks, Box Assignments
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Attorney Docket No.: QTII 0000 US0
700038066

PATENT
REEL: 013835 FRAME: 0049

CH \$560.00 061325 09468378

Patent/Application No.	Filing Date/IssueDate
6,020,458	February 1, 2000
6,258,407	July 10, 2001
6,534,616	March 18, 2003
6,140,456	October 31, 2000
6,086,679	July 11, 2000
6,323,297	November 27, 2001
6,051,321	April 18, 2000
09/468,378	December 20, 1999
6,049,086	April 11, 2000
6,015,759	January 18, 2000
6,079,353	June 27, 2000
6,114,227	September 5, 2000
60/138,898	June 11, 1999
09/591,613	June 9, 2000

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CORPORATE TO CORPORATE
ASSIGNMENT OF PATENTS, APPLICATIONS, AND INVENTIONS

WHEREAS, Quester Technology, Inc., a corporation organized and previously existing under the laws of the State of California and having had a principal place of business at 47633 Westinghouse Drive, Fremont, California (hereinafter "ASSIGNOR") and being merged as of January 17, 2002, into Canon U.S.A. Inc., a corporation organized and existing under the laws of New York, having a principal place of business at One Canon Plaza, Lake Success, New York (hereinafter "ASSIGNEE"), was the owner of all right, title and interest in the following Letters Patents and applications therefor:

United States Patent No. 6,020,458

Issued: February 1, 2000

Title: Precursors For Making Low-dielectric Constant Materials With Improved Thermal Stability

Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiano

Application No.: 08/957,481; Filing Date: October 24, 1997

Attorney Docket No.: QTI 8020 US0 SRM/DBB

United States Divisional Patent No.: 6,258,407

Issued: July 10, 2001

Title: Precursors For Making Low-dielectric Constant Materials With Improved Thermal Stability

Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiano

Application No.: 09/440,297; Filing Date: November 15, 1999

Attorney Docket No.: QTI 8020 DIV2 SRM/DBB

United States Divisional Patent No.: 6,534,616

Issued: March 18, 2003

Title: Precursors For Making Low-dielectric Constant Materials With Improved Thermal Stability

Application No.: 09/836,815; Filing Date: April 27, 2001

Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiano

Attorney Docket No.: QTI 8020 DIV1 SRM/DBB

United States Patent No: 6,140,456**Issued: October 31, 2000****Title: Chemicals and Processes for Making Fluorinated Poly(paraxylenes)****Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiate****Application No.: 08/957,792; Filing Date: October 24, 1997****Attorney Docket No.: QTII 8021 US0 SRM/DBB****United States Patent No: 6,086,679****Issued: July 11, 2000****Title: Deposition Systems and Processes for Transport Polymerization and Chemical Vapor Deposition****Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiate****Application No.: 08/958,352; Filing Date: October 24, 1997****Attorney Docket No.: QTII 8022 US0 SRM/DBB****United States Patent No.: 6,323,297****Issued: November 27, 2001****Title: Low Dielectric Constant Materials with Improved Thermal and Mechanical Properties****Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiate****Application No.: 08/958,057; Filing Date: October 24, 1997****Attorney Docket No.: QTII 8023 US0 SRM/DBB****United States Patent No.: 6,051,321****Issued: April 18, 2000****Title: Low Dielectric Constant Materials Prepared from Photon or Plasma Assisted Chemical Vapor Deposition and Transport Polymerization of Selected Compounds****Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiate****Application No.: 08/957,480; Filing Date: October 24, 1997****Attorney Docket No.: QTII 8024 US0 SRM/DBB****United States Divisional Application****Title: Low Dielectric Constant Materials Prepared from Photon or Plasma Assisted Chemical Vapor Deposition and Transport Polymerization of Selected Compounds****Inventors: Chung J. Lee, Hui Wang, Giovanni Antonio Foggiate****Application No.: 09/468,378; Filing Date: December 20, 1999****Attorney Docket No.: QTII 8024 DIV1 SRM/DBB**

United States Patent No. 6,049,086**Issued: April 11, 2000****Title: Large Area Silent Discharge Excitation Radiator****Inventors: Giovanni Antonio Foggiato, Leonid V. Velikov, Ralph F. Manriquez,
Ashraf R. Khan****Application No.: 09/022,507; Filing Date: February 12, 1998****Attorney Docket No.: QTII 8027 US0 SRM/DBB****United States Patent No. 6,015,759****Issued: January 18, 2000****Title: Surface Modification of Semiconductors Using Electromagnetic
Radiation****Inventors: Ashraf R. Khan, et al.****Application No.: 08/986,916; Filing Date: December 8, 1997****Attorney Docket No.: QTII 8035 US0 SRM/DBB****United States Patent No. 6,079,353****Issued: June 27, 2000****Title: Chamber for Reducing Contamination During Chemical Vapor
Deposition****Inventors: Leksell, Ming Xi Chan, Joseph P. Ellul, Jeanne L. Luce, David T.
Ryan, Iqbal A. Shareef, Chung J. Lee Stephen M. Campbell, Giovanni
Antonio Foggiato****Application No. 09/050,228; Filing Date: March 28, 1998****Attorney Docket No.: QTII 8039 US0 SRM/DBB****United States Patent No: 6,114,227****Issued: September 5, 2000****Title: Chamber for Reducing Contamination During Chemical Vapor
Deposition****Inventors: David Leksell, Ming Xi Chan, Joseph P. Ellul, Jeanne L. Luce, David
T. Ryan, Iqbal A. Shareef, Chung J. Lee Stephen M. Campbell,
Giovanni Antonio Foggiato****Application No.: 09/280,258; Filing Date: March 29, 1999****Attorney Docket No.: QTII 8039 US1 SRM/DBB****United States Provisional Patent Application****Title: Methods for Regulating Surface Sensitivity of Insulating Films in
Semiconductor Devices****Inventors: Ramanathan, Joseph Ellul, Ashraf Khan, Hariram Krishnamoorthy,
Dilip Vijay, Giovanni Foggiato****Application No.: 60/138,898; Filing Date: June 11, 1999****Attorney Docket No.: QTII 8045 PR SRM/DBB**

United States Utility Patent Application

Title: **Methods for Regulating Surface Sensitivity of Insulating Films in Semiconductor Devices**

Inventors: Sasangan Ramanathan, Joseph Ellul, Ashraf Khan, Hariram Krishnamoorthy, Dilip Vijay, Giovanni Foggiato

Application No: 09/591,613; Filing Date: June 9, 2000

Attorney Docket No.: QTI 8045 US0 SRM/DBB

WHEREAS, PATENT PROPERTY shall include each and all of the following:

(a) the foregoing Letters Patents and applications therefor and the inventions disclosed therein, and all embodiments of such inventions heretofore assigned to ASSIGNOR [all collectively hereinafter termed "said inventions"];

(b) all rights to apply in any and all countries of the world for patents, certificates of invention or other governmental grants on said inventions, including the right to apply for patents pursuant to the International Convention for the Protection of Industrial Property or pursuant to any other convention, treaty, agreement or understanding;

(c) any and all applications filed and any and all patents, certificates of invention or other governmental grants granted on said inventions in the United States or any other country, including each and every application filed and each and every patent granted on any application which is a division, substitution, or continuation of any of said applications;

(d) each and every reissue or extension of any of said patents;

(e) each and every patent claim resulting from a reexamination certificate for any and all of said patents, and

(f) the right to sue for and all claims for damages, profits or other recovery resulting from infringement, including past infringement, of any of the foregoing.

WHEREAS, by virtue of being the owner of all of Quester Technology, Inc. stock as indicated in the CERTIFICATE OF MERGER of QUESTER TECHNOLOGY, INC. INTO CANON U.S.A., INC., ASSIGNEE has acquired from ASSIGNOR the entire right, title and interest in and to said

PATENT PROPERTY. NOW THEREFORE, ASSIGNEE has caused this instrument to be executed by its duly authorized corporate officer this 28 day of July, 2003, in the State of California.

CANON USA, INC.

By: *Toshiya Oka*

Name: Toshiya Oka
(Type or Print)

Title: Director and Assistant General Manager of IP Division

State of California

County of Santa Clara

On July 28, 2003 before me, *Migi Guo*
(name and title of officer)

personally appeared Toshiya Oka, personally known to me (or proved to me on the basis of satisfactory evidence) to be the person(s) whose name(s) is/are subscribed to the within instrument and acknowledged to me that he/she/they executed the same in his/her/their authorized capacity(ies), and that by his/her/their signature(s) on the instrument the person(s), or the entity upon behalf of which the person(s) acted, executed the instrument.

WITNESS my hand and official seal.

Signature

[Handwritten Signature]

